

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Confirmation No.: 5377

Makiko KITAZOE, et al

Art Unit: 1792

Application No.: 10/591,905

Examiner: Keath T. CHEN

Filed: November 6, 2006

Attorney Docket No.: 029567-00010

For: SELF-CLEANING CATALYTIC CHEMICAL VAPOR DEPOSITION APPARATUS  
AND CLEANING METHOD THEREOF

**AMENDMENT UNDER 37 C.F.R. §1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

March 10, 2010

Sir:

In reply to the December 10, 2009, Office Action, please amend the above-identified application as follows:

Amendments to the claims, as reflected in the listing of claims, being on page 2;  
and

Remarks begin on page 8.